

40 C.F.R. § 60.683

Monitoring of operations.

- (a) An owner or operator subject to the provisions of this subpart who uses a wet scrubbing control device to comply with the mass emission standard shall install, calibrate, maintain, and operate monitoring devices that measure the gas pressure drop across each scrubber and the scrubbing liquid flow rate to each scrubber. The pressure drop monitor is to be certified by its manufacturer to be accurate within ± 250 pascals (± 1 inch water gauge) over its operating range, and the flow rate monitor is to be certified by its manufacturer to be accurate within ± 5 percent over its operating range.

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